

Notice of References Cited	Application/Control No. 10/587,502		Applicant(s)/Patent Under Reexamination TSUKAGOSHI ET AL.	
	Examiner JEFFERY WILLIAMS		Art Unit 2437	Page 1 of 1

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*	B	US-4,340,300	07-1982	Ruell, Hartwig	356/71
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NON-PATENT DOCUMENTS

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	U	Ljungblad et al., "New Laser Pattern Generator for DUV Using a Spatial Light Modulator", 2001, Elsevier Science, pg. 23-29.			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.